

PATENT



ATTY. DOCKET NO. TAZ/213

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Jozef Brcka

Art Unit: 1763

Serial No.: 10/O80,496

Examiner: L.L. Alejandro Mulero

Filed: February 22, 2002

For: MODIFIED TRANSFER FUNCTION DEPOSITION BAFFLES AND HIGH  
DENSITY PLASMA IGNITION THEREWITH IN SEMICONDUCTOR  
PROCESSING

**Petition for Extension of Time**

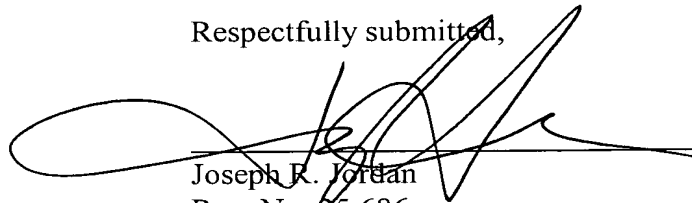
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant respectfully petitions for an extension of time of one (1) month from the original response date of April 8, 2004 for responding to the outstanding Office Action in the above-identified patent application. With the extension of time, the period for response now extends up to and includes May 10, 2004. A check for \$110.00 is enclosed herewith.

If any charges or credits are necessary to complete this communication, please apply them to Deposit Account 23-3000.

Respectfully submitted,



Joseph R. Jordan  
Reg. No. 25,686

Wood, Herron & Evans, L.L.P.  
2700 Carew Tower  
441 Vine Street  
Cincinnati, OH 45202-2917

Voice: (513) 241-2324

Facsimile: (513) 241-6234

05/12/2004 NROCHA1 00000038 10000496

01 FC:1251

110.00 0P